Tool Make & Model

APPLIED MATERIALS CENTURA HTF

Tool Configuration / Specifications

- Configured for 200mm	1	
- Centura 5200 HTF Toxic Epi mainframe	1	
- 480V/60Hz/600A	1	
- Widebody loadlocks	1	
- Wafer mapping	1	
- HP+ robot	1	
- OTF (on the flyer center finding)	1	
- Epi chamber, (ATM or RP) Position: A, B, C	3	
* R3.4 rotation assy		
* Variable Speed Blower		
* Quartz pyrometer (top and bottom)		
* Aux pyrometer		
* USHIO lamps		
* Stainless steel exhaust inserts		
* Fully refurbished rotation assy with anti-wobble		
- Flowpoint Control and Nano valves (ACCUSET control and valves)	1	
- Single slot noncontact cooldown chamber, position F	1	
- Standard gas panel with options to upgrade	1	
* New STEC digital MFCs		
* New Parker/Veriflo valves		
* New filters		
* New mixers		
* New gas lines		
* Gas Configuration (ex. ATM)		
H2, H2, HCL, TCS		
Mix Dop N – SCCM		Included
Mix Dop P – SCCM		Included
Pump purge to gas panel		Included

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